

MEMS Variable Optical Attenuator (MEMS VOA)

Description

MEMS VOA is an optical attenuator based on Micro-Electro-Mechanical System (MEMS) technology. The coupling efficiency is varied by applying a voltage to rotate the mirror. It is widely used in optical fiber communication systems, fiber lasers, optical fiber sensors and instrumentation.

Key Features

- Mini Size
- Low insertion loss
- Low Power Consumption

Applications

- Power management
- WDM System
- Test & Measurement
- Optical Instruments

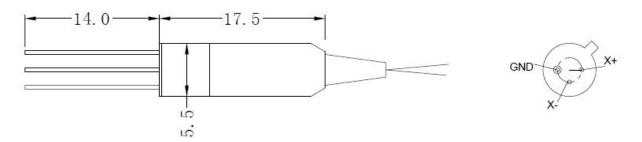
Specifications

Type	Unit	MEMS VOA	
Center wavelength	nm	840, 1064 etc.	1310, 1550 etc.
Bandwidth		±10	±20
Attenuation type	1	Bright or Dark	
Insertion loss	dB	≤1.0	≤0.8
Attenuation range	dB	≥25, 30, 40	
Polarization dependence loss @0 dB	dB	≤0.1	≤0.1
Polarization dependence loss @20 dB	dB	≤0.5	≤0.3
Return loss	dB	≥45	
Response Time	ms	≤5	
Handling power	mW	≤300	
Drive Voltage	V	≤8	
Fiber type	1	SM fiber	
Operating temperature	$^{\circ}$	-5~+70	
Storage temperature	$^{\circ}$	-40~+85	
Dimensions	mm	Ф5.5× L17.5	

^{*}IL is 0.2dB(1310~1550nm) or 0. 4dB(1064nm) or 0.8dB(840nm) higher, RL is 5dB lower for connector added.



Mechanical Dimension



Ordering Information

